
OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet**Application Information**

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R:	None
Title::	METHOD OF PRODUCING SOI WAFER AND SOI WAFER
Attorney Docket Number::	121026
Total Drawing Sheets::	3
Small Entity::	No

Applicant Information

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Hiroji
Family Name::	AGA
City of Residence::	Gunma
Country of Residence::	Japan

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Isao
Family Name::	YOKOKAWA
City of Residence::	Gunma
Country of Residence::	Japan

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Kiyotaka
Family Name::	TAKANO
City of Residence::	Gunma
Country of Residence::	Japan

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Kiyoshi
Family Name::	MITANI
City of Residence::	Gunma
Country of Residence::	Japan

Correspondence Information

Correspondence Customer Number:: 25944

Domestic Priority Information			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP03/16796	12/25/2003
Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2003-004833	01/10/2003	Yes
Assignee Information			
Assignee Name::	SHIN-ETSU HANDOTAI CO., LTD.		
Street of mailing address::	4-2, Marunouchi 1-chome,		
City of mailing address::	Chiyoda-ku,		
State or Province of mailing address::	Tokyo,		
Country of mailing address::	Japan		